

VIA EFS
Docket No.: 199372003910
(PATENT)
Client Ref. No. 146630US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Naoki SHINDO et al.

Application No.: 10/779,397

Confirmation No.: 2798

Filed: February 13, 2004

Art Unit: 1711

For: SUBSTRATE PROCESSING APPARATUS
AND SUBSTRATE PROCESSING METHOD

Examiner: Alexander Markoff

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

This is in response to the non-final Office Action dated June 23, 2010, for which a response is due on September 23, 2010. Reconsideration and allowance of the pending claims, as amended, in light of the remarks presented herein are respectfully requested.